

ISSUE CLASSIFICATION	
Class	Subclass

FILED UNDER 35 U.S.C. 871

**PATENT NUMBER**

**U.S. UTILITY Patent Application**

<b>O.I.P.E.</b> <i>M.I.T.</i> SCANNED <b>560</b> Q.A. <b>417</b>	<b>PATENT DATE</b>
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APPLICATION NO. 09/582049	CONT/PRIOR D F	CLASS 423	SUBCLASS 324	ART UNIT 1754	EXAMINER  N. Nguyen
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## REFERENCES

**TITLE**

PTO-2040  
12/99

## ABANDONED

## Method and installation for refining silicon

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## ISSUING CLASSIFICATION

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